## Information disclosure Statement

10/562129

Application#: PCT/US2004/019438
.IC10 Rec'd PC7/PTO 15 DEC 2005

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Patent #	Issue Date	Inventor(s)	
5,598,845	February 4, 1997	Chandraratna; P. Anthony (Rancho Palos Verdes, CA); Stern; Roger A. (Cupertino, CA)	
6,740,040	May 25, 2004	Mandrusov; Evgenia (Campbell, CA); Steward; Jeffrey (Lakewood, CO); Sherman; Marshall (Cardiff-by-the-Sea, CA)	·
6,428,477	August 6, 2002	Mason; Martin K (Andover, MA)	
5,735,280	April 7, 1998	Sherman; Marshall L. (Cardiff, CA); Castellano; Thomas M. (Temecula, CA)	
5,879,314	March 9, 1999	Peterson; Thomas M. (Erie, PA); Dharmendra; Pal (Erie, PA); DeCastro; Eugene (Jamestown, NY)	
6,424,597	July 23, 2002	Bolomey; Jean-Charles (Paris, FR); Cattiaux; Gerard (Chateaufort, FR); Chatillon; Sylvain (Nevilly sur Marne, FR); Joisel; Alain (Meudon, FR); Serre; Marc (Versailles, FR)	
4,505,156	March 19, 1985	Questo; Warren O. (Orangevale, CA)	
6,097,671	August 1, 2000	Merewether; Ray (La Jolla, CA)	
4,604,543	August 5, 1986	Umemura; Shinichiro (Hachiouji, JP); Takeuchi; Hiroshi (Matsudo, JP); Katakura; Kageyoshi (Meguro, JP); Shinomura; Ryuichi (Kokubunji, JP)	
5,142,649	August 25, 1992	O'Donnell; Matthew (Ann Arbor, MI)	
US 2002/0091339 A1	July 7, 2002	Horzewski; Michaeal J. (San Jose, CA (US)); Kaganov; Alan L. (Portola Valley, CA (US)); Suorsa; Veijo T. (Sunnyvale, CA (US)); Thompson; Todd A. (San Jose, CA (US))	
5,656,015	August 12,1997	Young; Michael John Radley (Ashburton, GB)	;
US 2002/0111568 A1	August 15, 2002	Bukshpan; Shmuel (Ramat Hasharon (IL))	

## JC10 Rec'd PCIPTO 15 DEC 2005 Information disclosure statement

## Application #: PCT/US2004/019498

Title	Publishing Date	Author(s)		
			•	
Properties of PZT- Based Piezoelectric Ceramics Between – 150 and 250 degrees Celsius	09/98	Hooker; M.W. (Lockheed Martin Engineering & Sciences Co., Hampton, Virginia)		
Fabrication of Pb(Nb,Ni)O3— Pb(Zr,Ti)O3 Piezoelectric Ceramic Fibers by Extrusion of a Sol— Powder Mixture	04/28/03	Jinhao; Q; Tani; J Yanada; N Kobayashi; Y (Institute of Fluid Science, Tohoku University, Katahira 2-1-1, Aoba-ku, Sendai 980-8577, Japan); Takahashi; H (Fuji Ceramics Co. Ltd., Shiznoka 418-0111, Japan)		